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Expired Mail No. ET160381508US
Attorney Docket No.: AM-2090P1.C1/2090.C2
1746

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Jeng H. Hwang et al.

§ GROUP ART UNIT: Unknown

SERIAL NO.: 09/896,786

§
§ EXAMINER: Unknown

FILED: June 29, 2001

§
§
§

FOR: METHOD FOR ALLOWING A STABLE POWER
TRANSMISSION INTO A PLASMA PROCESSING
CHAMBER

§
§ Attorney Docket No.:
§ AM-2090P1.C1/2090.C2

Date: July 20, 2001

INFORMATION DISCLOSURE STATEMENT
TRANSMITTAL LETTER

Hon. Commissioner for Patents
Washington, DC 20231

RECEIVED
AUG 06 2001
TC 1700

Sir:

Applicants are submitting the subject Information Disclosure Statement under 37 CFR § 1.97(b)(1). This Information Disclosure Statement is being submitted within three (3) months of the filing date of the subject application.

CERTIFICATE OF MAILING UNDER 37 CFR 1.10

I hereby certify that this paper is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. EXPRESS MAIL NO. ET160381508US in an envelope addressed to the: Commissioner for Patents, Box DD, Washington, DC 20231.

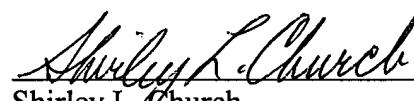
Date: July 20, 2001

Shirley L. Church
Shirley L. Church, Reg. No. 31,858

Applicants do not believe that any fee is due in connection with the filing of this Information Disclosure Statement under 37 CFR § 1.97(b)(1). However, in the event that any additional fee is due, the Commissioner is hereby authorized to charge Deposit Account No. 50-1512 of Shirley L. Church, Sunnyvale, California, in the amount of such fee.

This transmittal letter is submitted in duplicate for accounting purposes.

Respectfully submitted,



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